

Special Issue

Novel Approaches for Remote Sensing Image Processing

Message from the Guest Editors

This Special Issue is focused on hyperspectral image processing, image classification, unmixing, sub-pixel mapping, change detection on multi-remote sensing images, artificial intelligence and machine learning in remote sensing, and the geological applications of remote sensing. This Special Issue aims to collect original research and review articles related to approaches for remote sensing image processing. Themes of particular interest for this collection include, but are not limited to:

- hyperspectral image processing
- classification
- sub-pixel mapping
- change detection
- artificial neural networks
- geological remote sensing

Guest Editors

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About the Journal

Message from the Editor-in-Chief

As the world of science becomes ever more specialized, researchers may lose themselves in the deep forest of the ever increasing number of subfields being created. This open access journal Applied Sciences has been started to link these subfields, so researchers can cut through the forest and see the surrounding, or quite distant fields and subfields to help develop his/her own research even further with the aid of this multi-dimensional network.

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